NIN THE UNITED STATES	PATENT AND TRADEMARK OFFICE	2814
In re Patent Application of Att	y Dkt. 1035-243 C# M#	
SASAKI AUG 2 1 2003 Group Art l	Jnit: 2814	•
Serial No. 09/487,259 Exam	niner: A. Mai	
Filed: January 19, 2000 FAREUM	Date: August 21, 2003	
Title: METHOD OF MANUFACTURING SEMICONDUCTOR ETCHING	OR DEVICE USING CHEMICAL	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		
Sir:	/AMENDMENT/LETTED	
RESPONSE/AMENDMENT/LETTER  This is a response/amendment/letter in the above-identified application and includes an attachment which is hereby incorporated by reference and the signature below serves as the signature to the attachment in the absence of any other signature thereon.		
	orm Attached.	
Fees are attached as calculated below:  Total effective claims after amendment 48 minupreviously paid for 42 (at least 20) = 6	us highest number x \$ 18.00	\$ 108.00
Independent claims after amendment 6 minupreviously paid for 5 (at least 3) = 1	us highest number x \$ 84.00	\$ 84.00
If proper multiple dependent claims now added for first	time, add \$280.00 (ignore improper)	\$ 0.00
Petition is hereby made to extend the current due date:		•
paper and attachment(s) (\$110.00/1 month; \$410.00/2 mo		\$ 0.00
Terminal disclaimer enclosed, add \$ 110.00		\$ 0.00
<ul><li>☐ First/second submission after Final Rejection pursu</li><li>☐ Please enter the previously unentered , fi</li><li>☐ Submission attached</li></ul>	ant to 37 CFR 1.129(a) (\$750.00) iled	\$ 0.00
	Subtotal	\$ 192.00
If "small entity," then enter half (1/2) of subtotal and sub Applicant claims "small entity" status.	otract Statement filed herewith	-\$ 0.00
Rule 56 Information Disclosure Statement Filing Fee (\$	180.00)	\$ 0.00
Assignment Recording Fee (\$40.00)		\$ 0.00
Other:		0.00
	TOTAL FEE ENCLOSED	
The Commissioner is hereby authorized to charge any asserted to be filed, or which should have been filed hereim) to our Account No. 14-1140. A duplicate copy of the commission of the commissi	deficiency, or credit any overpayment, in the fee(s) file rewith (or with any paper hereafter filed in this application	ed, or
Arlington, Virginia 22201-4714 B Telephone: (703) 816-4000	Signature: Michael J. Shea, Reg. No. 34,725	
MJS:dbp S	ignature: Michael Phia	<del>\$ 17</del>
		AUG 26 203

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application:

SASAKI

Atty. Ref.:

1035-243

Serial No.:

09/487,259

Group:

2814

Filed:

January 19, 2000

Examiner:

A. Mai

For:

METHOD FOR MANUFACTURING A SEMICONDUCTOR

DEVICE USING CHEMICAL ETCHING

\*\*\*\*\*\*\*

August 21, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the office action dated May 21, 2003, please amend the subject patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

An **Amendment to the Title** is reflected on page 14 of this paper.

**Remarks** begin on page 15 of this paper.

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01 FC:1201 02 FC:1202 84.00 OP 108.00 OP